

Notice of References Cited

Application/Control No.

10/065,738

Applicant(s)/Patent Under
Reexamination
OKUBO ET AL.

Examiner

John Juba

Art Unit

2872

Page 1 of 2

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2002/0063941 A1	05-2002	Matsushita et al.	359/282
	B	US-2002/0003665 A1	01-2002	Mearini et al.	359/586
	C	US-6,421,303	07-2002	Inoue et al.	369/13.01
	D	US-6,031,970	02-2000	Nordal et al.	392/407
	E	US-5,901,021	05-1999	Hirano et al.	360/122
	F	US-5,750,210	05-1998	Schmidt et al.	427/577
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 05-273425 A	10-1993	Japan	Semicond Energy Lab Co.	---
	O	JP 2002-260922 A	09-2002	Japan	Japan. Science & Techn.	---
	P	WO 02/070793 A1	09-2002	WIPO	Japan Science & Techn.	---
	Q	JP 2000-162566 A	06-2000	Japan	TOKYO INST. of TECHN.	---
	R	JP 2000-267057 A	09-2000	Japan	RICOH CO LTD	---
	S	JP 11-030770 A	02-1999	Japan	RICOH CO LTD	---
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	I.A. Faizrahmanov, et al., "Influence of Xe+ ion irradiation on the microstructure of diamond-like carbon films", Vacuum Vol. 62, no. 1, pp. 15 - 19, 25 MAY 2001.
	V	I.A. Faizrahmanov, et al., "The Effect of Bombardment with Carbon Ions on the Nanostructure of Diamond-like Films", Semiconductors, Vol. 35, No. 5, pp.591-597, MAY 2001.
	W	Ken-ichi Kawamura, et al., "Holographic Encoding of Permanent Gratings Embedded in Diamond by Two Beam Interference of a Single Femtosecond Near-Infrared Laser Pulse", Jpn. J. Appl. Phys. Vol. 39, Part 2, No. 8a pp. L767-L769, 01 AUG 2000
	X	Jing Wang, et al., "Influence of the bombardment energy of (CH)n+ ions on the properties of diamond-like carbon films", Surface Coatings Techn. Vol. 122, no. 2-3, pp. 273-276, 15 DEC 1999.

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

Notice of References Cited

Application/Control No.

10/065,738

Applicant(s)/Patent Under
Reexamination
OKUBO ET AL.

Examiner

John Juba

Art Unit

2872

Page 2 of 2

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	W.J. Wang, et al., "Implantation effect of diamond-like carbon films by 110 keV nitrogen ions", Thin Solid Films, Vol. 280, no. 1-2, pp. 90-94, JULY 1996.
	V	V. Palshin, et al., "Characterization of ion-beam deposited diamond-like carbon films", Thin Solid Films Vol. 270, no. 1-2, pp. 165-172, 01 DEC 1995.
	W	G.A. Clarke, et al., "Characterization of magnetron-sputtered diamond-like thin films for optical coatings in the IR", Thin Solid Films Vol. 236, no. 1-2, pp. 67 - 71, 15 DEC 1993.
	X	M.E. Overberg, et al., "Indication of ferromagnetism in molecular-beam-epitaxy-derived N-type GaMnN", Appl. Phys. Lett. 79(9), pp. 1312-1314, 27 AUG 2001.

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.